



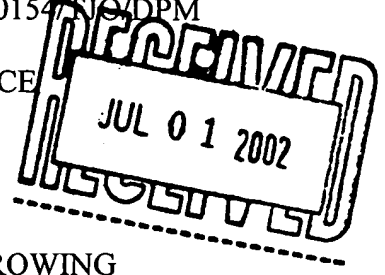
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Express Mail No.: EL 844 536 559 US
Date of Deposit: April 24, 2002

2811
July

Attorney's Docket No.: H00498.70154/TJO/DPM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant: Charles M. Lieber et al.
 Serial No: 09/935,776 ✓
 Filed: August 22, 2001
 For: DOPED ELONGATED SEMICONDUCTORS, GROWING
 SUCH SEMICONDUCTORS, DEVICES INCLUDING SUCH
 SEMICONDUCTORS AND FABRICATING SUCH DEVICES
 Examiner: Not Yet Assigned
 Art Unit: 2811

Commissioner For Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is/are the following document(s):

- Information Disclosure Statement
- PTO Form 1449 with cited references
- Return Receipt Postcard

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If the enclosed papers are considered incomplete, the Mail Room and/or the Application Branch is respectfully requested to contact the undersigned at (617) 720-3500, Boston, Massachusetts.

No fee is enclosed. If a fee is necessary, the Commissioner is hereby authorized to charge Deposit Account No. 23/2825. A duplicate of this sheet is enclosed.

Respectfully submitted,
Charles M. Lieber et al., Applicant(s)

Daniel P. McLoughlin, Reg. No.: 46,066
 Wolf, Greenfield & Sacks, P.C.
 600 Atlantic Avenue
 Boston, Massachusetts 02210-2211
 Attorneys for Applicant(s)

Docket No. H00498.70154/TJO/DPM
Date: April 24, 2002

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STATEMENT FILED PURSUANT TO THE DUTY OF
DISCLOSURE UNDER 37 CFR §§1.56, 1.97 AND 1.98

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §§1.56, 1.97 and 1.98, the Applicants requests consideration of this Information Disclosure Statement.

PART I: Compliance with 37 C.F.R. §1.97

This Information Disclosure Statement has been filed before the mailing date of a first Office Action on the merits in the above-identified case. No fee or certification is required.

PART II: Information Cited

The Applicant hereby makes of record in the above-identified application the information listed on the attached form PTO-1449 (modified). The order of presentation of the references should not be construed as an indication of the importance of the references.

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The Applicant hereby makes the following additional information of record in the above-identified application. The applicant would like to bring to the Examiner's attention the following co-pending applications that may contain subject matter related to this application:

| Serial No. | Filing Date | Title of Application | Attorney Dock. No. |
|------------|-------------|---|--------------------|
| 10/033,369 | 10/24/2001 | Nanoscopic Wire-Based Devices, Arrays, and Methods of their Manufacture | H00498/70112 |

PART III: Remarks

Documents cited on the attached form PTO-1449 (modified) are enclosed unless otherwise indicated on the attached form PTO-1449 (modified). It is respectfully requested that:

1. The Examiner consider completely the cited information, along with any other information, in reaching a determination concerning the patentability of the present claims;
2. The enclosed form PTO-1449 be signed by the Examiner to evidence that the cited information has been fully considered by the Patent and Trademark Office during the examination of this application;
3. The citations for the information be printed on any patent which issues from this application.

By submitting this Information Disclosure Statement, the Applicant makes no representation that a search has been performed, of the extent of any search performed, or that more relevant information does not exist.

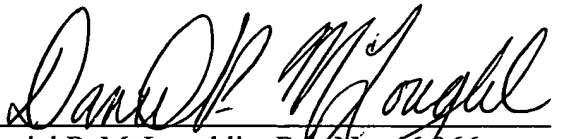
By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, in fact, prior art as defined by 35 U.S.C. §102.

Notwithstanding any statements by the Applicant, the Examiner is urged to form his own conclusion regarding the relevance of the cited information.

An early and favorable action is hereby requested.

Respectfully submitted,
Charles M. Lieber et al, Applicant(s)

By: 
Daniel P. McLoughlin, Reg No. 46,066
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600 Atlantic Avenue
Boston, MA 02210
Telephone (617) 720-3500

Docket No. H00498.70154/TJO/DPM
Dated: April 24, 2002
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